

03560.003451

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: Kevin C. Gutierrez
Yoshikazu MIYAJIMA et al.)	
	:	Group Art Unit: 2851
Application No.: 10/820,120)	
	:	Confirmation No.: 8660
Filed: April 8, 2004)	
	:	
For: STAGE APPARATUS, EXPOSURE SYSTEM)	January 5, 2007
USING THE SAME, AND DEVICE	:	
MANUFACTURING METHOD)	

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated October 5, 2006, please amend the above-identified application as follows: